



Docket No. 02-IMP-037

EATNP139US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ION BEAM PATENT application of:

Applicant: Benveniste
Application No.: 10/669,186
For: ION BEAM SLIT EXTRACTION WITH MASS SEPARATION
Filing Date: September 24, 2003
Examiner: David Vanore
Art Unit: 2881

REPLY TO OFFICE ACTION DATED JUNE 23, 2006

Mail Stop Amendment
Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following amendments and remarks.